

Attorney's Docket No.: 42P17282

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In Re Patent Application of:

Hok-Kim Choi, et al.

Application No: 10/750,199

Filing Date: December 30, 2003

For: A METHOD TO ASSAY
SACRIFICIAL LIGHT
ABSORBING MATERIALS AND
SPIN ON GLASS MATERIALS
FOR CHEMICAL ORIGIN OF
DEFECTIVITY

Examiner: Daniel S. Larkin

Art Unit: 2856

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on
January 31, 2006

(Date of Deposit)

Trina Chau

(Typed or printed name of person mailing correspondence)

 January 31, 2006

(Signature of person mailing correspondence) (Date)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME
PURSUANT TO 37 C.F.R. § 1.136 (a)

Sir:

Applicant respectfully petitions pursuant to 37 CFR 1.136(a) for a one-month extension of time to file this response to the Office Action mailed November 30, 2005. The extended period is set to expire on February 28, 2006. A check in the amount of \$120.00 is enclosed to cover the fee for a one-month extension of time.

Pursuant to 37 C.F.R. 1.136(a)(3), applicant(s) hereby request and authorize the U.S. Patent and Trademark Office to (1) treat any concurrent or future reply that requires a petition for extension of time as incorporating a petition for extension of time for the appropriate length of time and (2) charge all required fees, including extension of time fees and fees under 37 C.F.R. 1.16 and 1.17, to Deposit Account No. 02-2666.

02/06/2006 SHASSEN1 00000055 10750199

01 FC:1251

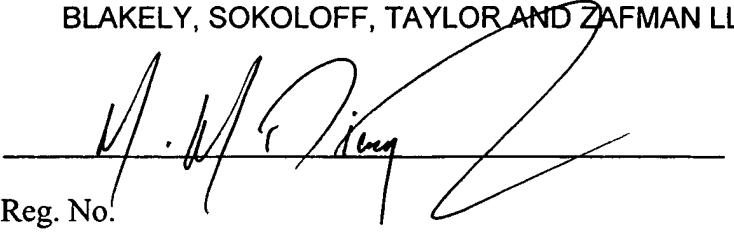
120.00 OP

Please charge any shortages and credit any overages to our Deposit Account No.
02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR AND ZAFMAN LLP

Dated: 1-31, 2006

Reg. No. 

12400 Wilshire Blvd.
Seventh Floor
Los Angeles, CA 90025
(408) 720-8300